

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of**

Chen, et al.

**Serial No.:** 09/748,256      **Group Art Unit:** 2811

**Filed:** December 27, 2000      **Examiner:** Ori Nadav

**For:** METHOD FOR FABRICATING COMPLEMENTARY METAL OXIDE  
SEMICONDUCTOR (CMOS) DEVICES ON A MIXED BULK AND SILICON-ON-  
INSULATOR (SOI) SUBSTRATE

Honorable Commissioner of Patents  
Alexandria, VA 22313-1450  
**BOX AF**

**SECOND AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

Applicant notes that this Amendment is filed concurrently with Appellant's Appeal Brief, and is substantially identical to the Amendment filed herein on January 21, 2004. Applicant respectfully submits that the claim amendments included herein clearly do not raise new issues and serve to clarify the issues on appeal. Therefore, this Amendment should be entered.

In response to the Final Office Action dated November 19, 2003, please amend the above-identified application as follows: